## Amendments to the Claims:

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The following listing of claims will replace all prior versions, and listings, of claims in the application.

- 1-36. (Canceled)
- 37. (New) A patterning method, comprising:

depositing a first liquid material to a first part between a first indent of a plurality of indents formed in a surface of a substrate and a second indent of the plurality of indents;

depositing a second liquid material to a second part between the first indent and a third indent of the plurality of indents; and

no material being deposited to a third part between the second indent and a fourth indent of the plurality of indents.

- 38. (New) The patterning method according to claim 37, the first liquid material being the same as the second liquid material.
- 39. (New) The patterning method according to claim 37, the first liquid material being different from the second liquid material.
- 40. (New) The patterning method according to claim 37, wherein a group of indents included in the first indent being formed between the first part and the second part.
- 41. (New) The patterning method according to claim 37, wherein the first indent has a width tapering towards the bottom.
- 42. (New) The patterning method according to claim 37, wherein the first indent has a width widening towards the bottom.
  - 43. (New) A patterning method comprising:

depositing a liquid material onto an indent region having wall portions which have slopes relative to a surface of a substrate; and

the slopes being arranged such that the indent region having widths widening towards a bottom of the indent region.

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- 44. (New) The patterning method according to claim 43 wherein the indent region is formed with a cross-sectional profile to provide a secondary barrier to further control the spread of the material over the surface.
- 45. (New) The patterning method according to claim 44 wherein the indent region is provided with a castellated cross-sectional profile.
- 46. (New) The patterning method according to claim 44 wherein the indent region is provided with a saw-tooth cross-sectional profile.
- 47. (New) The patterning method according to claim 44 comprising providing first and second indent regions of elongate shape and impressing a further elongate indent region arranged between but spaced from the first and second indent regions, the further indent region having a substantially planar bottom surface.
- 48. (New) A method of manufacturing an electronic device, the method comprising: making a pattern by the patterning method according to claim 37.
- 49. (New) The method according to claim 48,

  the first liquid material including a semiconductor material, and the second liquid material including a semiconductor material.
- 50. (New) The method according to claim 49,

  a source of a transistor and a drain of the transistor being formed in the first
  part and the second part, respectively; and
- a channel of the transistor being formed between the first part and the second part.
  - (New) A patterning method comprising:forming an indent region in the surface of a substrate;

depositing a liquid material onto the surface at selected locations such that spread of the material over the surface is controlled by the indent region;

wherein the indent region is formed with a cross-sectional profile to provide a secondary barrier to further control the spread of the material over the surface; and

wherein the material is selected to comprise a semiconductor material and the selected locations comprise the surface between the elongate indent regions so as to provide source and drain regions for a thin film transistor having a channel length determined by the width of the further elongate indent regions and a channel width determined by the length of the further elongate indent region.

52. (New) A patterning method comprising:

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forming an indent region in the surface of a substrate;

depositing a liquid material onto the surface at selected locations such that spread of the material over the surface is controlled by the indent region; and

adjusting the wetting characteristic of the surface of the substrate relative to the material to be deposited.

53. (New) A patterning method comprising:

forming an indent region in the surface of a substrate;

depositing a liquid material onto the surface at selected locations such that spread of the material over the surface is controlled by the indent region;

wherein the indent region is formed with a cross-sectional profile to provide a secondary barrier to further control the spread of the material over the surface; the method further comprising:

providing first and second indent regions of elongate shape;

impressing a further elongate indent region arranged between but spaced from the first and second indent regions, the further indent region having a substantially planar bottom surface; and

wherein the first and second indent regions are selected to comprise the crosssectional profile providing the secondary barrier.

54. (New) A patterning method comprising:

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forming an indent region in the surface of a substrate;

depositing a liquid material onto the surface at selected locations such that spread of the material over the surface is controlled by the indent region; and wherein the indent region or regions is/are provided using an impression

55. (New) A patterning method comprising:

technique and the surface is impressed using a stamping die.

forming an indent region in the surface of a substrate;

depositing a liquid material onto the surface at selected locations such that spread of the material over the surface is controlled by the indent region; and

wherein the indent region or regions is/are provided using an impression technique and the surface is impressed using a moulding technique.

56. (New) A patterning method comprising:

forming an indent region in the surface of a substrate;

depositing a liquid material onto the surface at selected locations such that spread of the material over the surface is controlled by the indent region; and

providing two juxtaposed elongate indent regions and wherein the material is selected to comprise a conductive material and the selected locations comprise the surface between the elongate indent regions, thereby to provide an electrically conductive electrode.

57. (New) A patterning method comprising:

forming an indent region in the surface of a substrate;

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depositing a liquid material onto the surface at selected locations such that spread of the material over the surface is controlled by the indent region; and wherein the indent region or regions is/are provided using an impression technique.

58. (New) A patterning method for depositing a liquid onto a surface of a substrate; said method comprising:

forming a first and second indent in the surface, each indent having falling edges co-incident with the surface and spaced a distance apart;

depositing said liquid between said indents; and

selecting the distance such that a greater volume of liquid is deposited and retained than in the absence of at least one of the indents.

- 59. (New) A patterning method according to claim 58, in which said forming said first and second indents includes forming wall portions sloping relative to the surface.
- 60. (New) A method of manufacturing an electronic device, the method comprising: making a pattern by the patterning method according to claim 58.
- 61. (New) A patterning method for depositing a liquid onto a surface of a substrate, said method comprising:

forming a first and second indent in the surface, each indent having falling edges co-incident with the surface and spaced a distance apart;

depositing said liquid between said indents; and

selecting the distance such that a greater contact angle between the liquid and the surface is provided than in the absence of at least one of the indents.

62. (New) A patterning method according to claim 61, in which said forming said first and second indents includes forming wall portions sloping relative to the surface.

63. (New) A method of manufacturing an electronic device, the method comprising: making a pattern by the patterning method according to claim 61.

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64. (New) A patterning method for depositing a liquid onto a surface of a substrate, said method comprising:

forming a first and second indent in the surface, each indent having falling edges co-incident with the surface and spaced a distance apart;

depositing said liquid between said indents; and

selecting the distance such that the diameter of the deposited liquid is greater than the distance.

- 65. (New) A patterning method according to claim 64, in which said forming said first and second indents includes forming wall portions sloping relative to the surface.
- 66. (New) A method of manufacturing an electronic device, the method comprising: making a pattern by the patterning method according to claim 64.
- 67. (New) A patterning method for depositing a liquid onto a surface of a substrate, said method comprising:

forming a first and second indent in the surface, each indent having falling edges co-incident with the surface and spaced a distance apart;

depositing said liquid between said indents; and

selecting the distance such that the thickness of the liquid deposited and retained is greater than in the absence of at least one of the indents.

- 68. (New) A patterning method according to claim 67, in which said forming said first and second indents includes forming wall portions sloping relative to the surface.
- 69. (New) A method of manufacturing an electronic device, the method comprising: making a pattern by the patterning method according to claim 67.